

Transaction Information

Tool ID	CVD2210U1
Tool Status	Warehouse
Location	Malta, USA
Wafer Size	300 mm
Fab Section	Thin Film
Tool Available Date	2021-01-13

General Product Information

Vendor Supplier	LAM
Model	ALTUS , 1 FFWN/W Chamber
Vintage	2013
Serial No	NA
Asset Description	R&D Chamber, never installed on CVD2210 mainframe
Software Version	NA
CIM	NA
Process	TFM_W Dep

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	LAM Inflection, 1 FFWN/W Dep Chamber	1	OK
Handler System	NONE	0	OK
Factory Interface	NONE	0	OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NONE		

Missing/Faulty Parts / Accesories List

Description	Quantity
NO MISSING PARTS	0

Tool Pictures

General

NONE



Manufacture Serial

NONE



Additional Configuration Files